

In re Patent Application of

NAITOH

Atty. Ref.: 4074-12; Confirmation No. 5563

Appl. No. 10/808,398

TC/A.U. 2891

Filed: March 25, 2004

Examiner: Anya, Igwe

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, FLEXIBLE

SUBSTRATE, AND SEMICONDUCTOR DEVICE

September 1, 2006

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

<u>AMENDMENT AFTER FINAL</u>

Responsive to the Official Action dated June 2, 2006, please amend the above-identified application as follows. Given the Examiner's indication of allowable subject matter, this amendment places the application in condition for allowance.